Minimally invasive spin sensing with scanning tunneling microscopy†

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Minimizing the invasiveness of scanning tunneling measurements is paramount for observation of the magnetic properties of unperturbed atomic-scale objects. We show that the invasiveness of STM inspection on few-atom spin systems can be drastically reduced by means of a remote detection scheme, which makes use of a sensor spin weakly coupled to the sensed object. By comparing direct and remote measurements we identify the relevant perturbations caused by the local probe. For direct inspection we find that tunneling electrons strongly perturb the investigated object even for currents as low as 3 pA. Electrons injected into the sensor spin induce perturbations with much reduced probability. The sensing scheme uses standard differential conductance measurements, and is decoupled both by its non-local nature, and by dynamic decoupling due to the significantly different time scales at which the sensor and sensed object evolve. The latter makes it possible to effectively remove static interactions between the sensed object and the spin sensor while still allowing the spin sensing. In this way we achieve measurements with a reduction in perturbative effects of up to 100 times relative to direct scanning tunneling measurements, which enables minimally invasive measurements of a few-atom magnet’s fragile spin states with STM.

The process of measuring an object can impact its state. This often unwanted effect, also called the observer effect, is striking for quantum phenomena1,2 and remarkably important for the investigation of atomic scale objects. In particular, the magnetic stability of atomic-scale magnets is extremely sensitive to small variations in their local environment,3,4 whether intrinsic or measurement induced.5,6 Minimizing the invasiveness of the measurement process is critical for the observation of unperturbed atomic-scale magnets. This has to be taken into special consideration when trying to harness their magnetic states for data storage,7,8 spintronics8 and quantum computing.9–11

Scanning probe microscopy has become an essential tool11 for probing magnetic surfaces,12–14 atoms,15–18 atom chains,19,20 and molecules.21–28 All scanning probe techniques – irrespective of whether they use magnetic forces or spin-polarized current for detection – require the presence of a local probe tip. Its proximity can perturb the investigated object, through mechanical interaction,29–32 magnetic stray field,33 electric fields,23,29,34–37 magnetic exchange coupling12,14,38 as well as electron injection.7,39 Whereas magnetic force and magnetic exchange force microscopy have been used to great effect for the investigation of extended magnetic surfaces without the use of electric current, the majority of atomic-scale magnetic structures have been studied with STM where the impact of the tunneling electrons must be considered.

Here, we demonstrate that the invasiveness of direct STM inspection can be minimized and quantified via a remote detection scheme using a spin sensor. This remote detection scheme is inspired by optical quantum non-demolition measurements2 and a recent report where ESR-STM was used to detect the state of a nearby magnetic atom.40 An indirect observation of the object’s spin state is performed by measuring a nearby sensor spin weakly coupled to the sensed object. This substantially reduces the perturbation induced by the STM measurements, while also allowing the perturbation to be identified by comparison with direct inspection data.

We demonstrate that by using a kinked chain of three iron atoms as a sensor spin, minimally invasive measurements of a
nearby eight-atom nano-antiferromagnet (nano-AF) can be performed. The nano-AF was chosen because transitions between its Néel-like ground states are determined by magnetic tunneling and variations of the switching rate are a direct measure for the invasiveness of the sensing scheme. In the scope of this work, intrinsic switching rates refer to the time evolution of the isolated spin system on a surface in absence of probe induced perturbations. In particular, we show a possible route to minimize the perturbation induced by STM investigation, shedding light on the many different aspects that one must take into account when designing minimally invasive measurements.

We find the tunneling current is the main perturbation for direct STM inspection, even for tunneling currents as low as 3 pA. The remote sensing scheme, explicitly avoiding direct tunneling, is 100 times less perturbative. To reach this level of isolation, we show that the sensing scheme must rely on spin states of the sensor spin mismatched to those of the sensed object. Furthermore, to effectively cancel the sensor-nano-AF interaction a dynamic decoupling scheme is employed by making use of the rapid switching of the sensor’s magnetic states during the measurement. This approach effectively allows the primary STM induced perturbations of the magnetic dynamics of the nano-AF to be suppressed, and, by comparison with direct inspection data, identified. As such, our report establishes a general method of tailoring the sensing scheme to mitigate STM induced perturbations.

Both the sensor spin and the nano-AF were assembled with Fe atoms on a monatomic layer of Cu$_2$N grown on Cu(100), Fig. 1a. Fe atoms on Cu$_2$N have a spin of magnitude 2 and exhibit large easy-axis magnetocrystalline anisotropy ($z$ direction, Fig. 1b) with a small transverse anisotropy contribution.\textsuperscript{41,42} The Cu$_2$N surface mediates long-range magnetic interaction through $x$ and $\sigma$ states of the Cu–N network, allowing remote spin sensing via weak $\mu$eV-scale interaction between nano-AFs.\textsuperscript{43}

The nano-AF consists of two parallel rows of four Fe atoms each.$^7$ In this arrangement the iron atoms couple antiferromagnetically; the nano-AF features two stable Néel-like ground states (labelled state ‘0’ and state ‘1’) and is insensitive to external magnetic fields.$^7$ We therefore consider the effect, if any, of the external magnetic field to be part of the nano-AF environment. A spin-polarized tip was prepared by functionalizing the apex with Fe atoms picked up from the surface. The external magnetic field (see Fig. 1g) determines the direction of the tip polarization.\textsuperscript{44} Topographic imaging with a spin-polarized tip resolves these two states as a checkerboard-pattern in the apparent height of the constituent Fe atoms, Fig. 1a and b. At low temperature (0.5 K), the spontaneous switching of the nano-AF between the two Néel-like states is sufficiently slow to be detected by conventional STM measurements. Time traces of this switching can be recorded by monitoring the variations in apparent height of any atom of the nano-AF, Fig. 1d. This direct measurement on the nano-AF gives an average time between switching events in the tens of seconds.$^{45}$

The sensor is comprised of three iron atoms arranged in a kinked chain, Fig. 1g. In this configuration the middle atom couples antiferromagnetically to the first and ferromagnetically to the third, as confirmed by spin-resolved topographies Fig. 1a, b and 2a. This geometry was selected because of its long spin relaxation time (2.8 $\mu$s in 2 T magnetic field, ESI S1$^\dagger$), as well as the strong dependence of its $dI/dV(V)$ spectra on the external magnetic field, Fig. 2b. In particular, when measuring spectra with a spin-polarized tip and a 2 T field along the Fe’s magnetic easy axis, the main features are due to spin excitations between short- and long-lived spin states.

We find that $dI/dV(V)$ spectra acquired over the third atom of the sensor show a significant signal variation, depending on the nano-AF state. This is most prominent at the minimum ($dip$) at $-5.4$ mV bias, Fig. 1c. The correlation between the two nano-AF Néel-like states and the high and low conductivity states of the sensor spin is reported in Fig. 1f. This was verified by rapidly moving the tip between the nano-AF and the sensor spin (see details in ESI S2$^\dagger$); hence, the time evolution of the signal at $-5.4$ mV, denoted ($dI/dV$)$_{dip}$, remotely monitors the nano-AF switching, Fig. 1e. It is worth noting that the switching rate measured by remote sensing is an order of magnitude slower than that measured by direct inspection, an indication that direct inspection with the tip on the nano-AF is strongly perturbative in comparison with remote sensing.

To quantify how effective the remote conductance-based sensing mechanism is, we analyzed the signal-to-noise ratio (S/N) (see ESI S3 and S4$^\dagger$) as a function of bias voltage and tunnel current setpoints. The bias voltage dependence shows that the sensor is capable of detecting the nano-AF switching in 1 mV windows centered at positive and negative 5.2 mV bias. The best performance, a S/N of 8, is observed at $-5.2$ mV, Fig. 3a. The dependence of the S/N on tunnel current magnitude was evaluated at this voltage. It increases rapidly as the current setpoint is raised from 100 pA to 750 pA, where a maximum is reached, and then decreases slightly for higher currents, Fig. 3b. The noise magnitude in the sensor measurement depends linearly on the current (as experimentally confirmed, see ESI S4$^\dagger$). Since the current dependence of the signal to noise ratio shows a non-monotonic behavior, the measured signal must have a non-linear response. This points to a non-trivial role of the electron tunneling rate in the sensing signal, as confirmed by the model discussed below, which shows that the ($dI/dV$)$_{dip}$ signal is of dynamic origin.$^{45}$

We then use a rate equation model,$^{45}$ which accounts for electron–spin scattering, to analyze the sensing scheme. It accurately reproduces the position and magnitude of all spectral features in the sensor’s $dI/dV(V)$ (see ESI S5$^\dagger$). The tunneling process responsible for the ($dI/dV$)$_{dip}$ signal variation is identified as inelastic tunneling that excites the sensor’s spin from its ground state $|+2, -2, -1\rangle$ to the excited state $|+2, -2, -1\rangle$ ($+2, -2, -1$ and $|+z, -2, -1\rangle$ are the $S_z$ expectation values of atom 1, 2, and 3, respectively, with $z$ parallel to the external magnetic field). This is corroborated by the shift of the dip when changing the external magnetic field, Fig. 2b, in agreement with the Zeeman shift of the states, Fig. 2c.
Notably, the rate equation model indicates that the elaborate shape of the spectra is due to spin pumping effects.44,45 This dynamic process takes place when electron tunneling events occur on a time scale shorter than the sensor spin relaxation time. In the sensor, this is achieved via the long-lived metastable state |−2, +2, +2〉. Pump probe measurements determine its average lifetime to be 2.8 μs, and confirm the presence of the spin pumping mechanism (see ESI S1†). The (dI/dV)dip signal is therefore the consequence of averaging the conductance signals of different spin states; each state’s contribution depends on its average population in dynamic equilibrium.45

Use of a non-local sensor avoids direct tunneling through the nano-AF, however, hot electrons generated in the tunneling processes may still propagate from the sensor to the nano-AF. This effect has been reported to trigger chemical reactions at tens of nanometers distance.47 To mitigate this effect, the sensor spin was designed to have the spin excitation, responsible for the (dI/dV)dip signal, at 5.2 meV. This is at a lower energy than the allowed nano-AF spin excitations at 6.5 meV and 8.4 meV (Fig. 2e and f). As such, the energy of electrons injected at the sensor with −5.2 mV bias is insufficient to trigger a spin excitation in the nano-AF. Further measurements using spin pumping features on the other atoms of the spin

Fig. 1 Direct and remote measurement of the nano-AF’s switching. (a) Spin-polarized STM image of the nano-AF in spin state ‘0’ (left structure consisting of 8 Fe atoms) and the spin sensor (right structure consisting of 3 Fe atoms). The distance between the nano-AF and the sensor is 1.9 nm; tunnel junction setpoint 4 mV, 5 pA. (b) Same area as (a) with the nano-AF in state ‘1’. Arrows labeled x, y, z show the reference coordinate system. (c) (dI/dV) spectra acquired with the tip positioned over the sensor (blue star in (b)) when the nano-AF is in state ‘0’ (red line) or ‘1’ (blue line). Inset shows the zoom of the pronounced dip at −5.4 mV bias voltage highlighting the (dI/dV)dip used for the sensing scheme. (d) Time trace of the tip position, Y, with the spin-polarized tip over the nano-AF (green star in (b)). STM feedback loop set to maintain constant current 2 pA at −3 mV bias. (e) Time trace of the (dI/dV)dip signal recorded with the tip over the sensor (blue star in (b)). STM feedback loop set to maintain constant current 150 pA at −5.2 mV bias. AC bias modulation for detection is 720 μV. Two-state switching of the nearby nano-AF appears as jumps in (dI/dV)dip at much reduced rate compared to (d) despite 50-fold increased tunnel current. (f) Correlation plot between the nano-AF state observed with the tip over the nano-AF and (dI/dV)dip obtained by measurement on the sensor. (g) Schematic representation of the Fe atom sensor on the Cu2N surface showing surface Cu atoms (dark blue), N atoms (light blue), Fe atoms (green). Arrows on Fe atoms indicate the magnetic moment orientation in the external magnetic field. All measurements were acquired at 2 T magnetic field along the Z direction.
sensor indicate that slow switching rates can only be observed for voltages below the spin excitation threshold of the nano-AF. Our model indicates a clear correlation between the nano-AF’s spin state and additional spin pumping features on the first and second atoms of the spin sensor. For sensor spin features above threshold, such as those at $-7.2$ mV on the first atom and $-8.5$ mV on the second, the switching is faster than the bandwidth of our measurement. However, a spin pumping feature at $-5.5$ mV on the second atom, which is below the nano-AF threshold, can resolve the switching. Tailoring the sensor’s spin pumping features to be below the excitation threshold of the sensed object helps to minimize the perturbative nature of the measurement.

The model also allows the surface mediated interaction, through $\pi$ and $\sigma$ states of the Cu$_2$N network, between the nano-AF and the sensor spin to be quantified (see section S4 and Table S1 of ESI†). The sensor is constructed such that only two atoms can interact with the nano-AF, for the third atom all magnetic interactions with the nano-AF cancel out due to geometric magnetic frustration (see ESI S6† for details). We find an effective exchange bias field of about 100 mT (see ESI S4†), which, in the absence of any further decoupling mechanism, would prohibit performing a non-perturbative measurement using the sensor. However, as we show below, the occupation probability of the two nano-AF ground states shows that the sensing scheme is almost non-perturbative.

Due to the degeneracy of the two Néel-like ground states, they will be equally occupied in the absence of perturbation. Any interaction that stabilizes one state, or promotes a state-dependent transition, leads to an unbalanced occupation. Indeed, direct measurements with the STM tip positioned on the nano-AF show a strong occupation imbalance. When the STM tip measures a peripheral atom (Fig. 4a left panel) the imbalance is 0.75 : 0.25 (state ‘0’ occupation : state ‘1’ occupation).
Conversely, when the STM tip measures a central atom it is 0.3 : 0.7 (Fig. 4a, middle panel). This imbalance matches to the spin-polarization of the tip, always favors the nano-AF state with the spin of the investigated atom aligned with that of the tip, and is independent of the tip–sample distance, i.e., current magnitude (see ESI S7†). This shows that the exchange interaction between magnetic tip and the nano-AF is negligible here as it would be strongly distance-dependent and favor anti-alignment.38 We thus conclude that the primary source of perturbation in the direct measurement scheme are the spin-polarized tunneling electrons.

In contrast to direct measurements, the occupation of the nano-AF states becomes balanced to within our measurement accuracy for the remote measurement for all current setpoints (see ESI S8†). This suggests that the perturbation induced by remote sensing is comparable to the intrinsic environmental perturbations experienced by the nano-AF, despite the significant surface-mediated interaction between sensor spin and nano-AF. In the presence of a sensor spin with static magnetization, this interaction would split the nano-AF states sufficiently so as to support an occupation imbalance of 0.75 : 0.25 (Boltzmann occupation calculated for 100 mT exchange bias field at 0.5 K temperature). But, during measurement, the sensor spin switches rapidly between states with opposite magnetization on the nano- to microsecond timescale. Hence, the balanced occupation observed indicates that the magnetic interaction with the sensor spin is effectively cancelled on the timescale of tens of seconds on which the nano-AF switches. This decoupling process is reminiscent of dynamic decoupling schemes employed in magnetic resonance spectroscopy.48 It is worth noting that minimizing per-

Fig. 3  Signal to noise analysis of the sensing scheme performance. (a) Signal-to-noise ratio for remote measurement of the nano-AF spin states as a function of applied DC bias. Tunnel current setpoint 300 pA. Blue dots are experimental data, the dotted lines are guides to the eye. (b) Signal-to-noise ratio as function of tunnel current setpoint with an applied DC bias –5.2 mV. Blue dots are experimental data, orange line is a fit obtained using our model (see ESI† for details).

Fig. 4  Quantitative analysis of measurement induced perturbation. (a) Time-averaged occupation of the two nano-AF states ‘0’ and ‘1’ for direct measurement with the tip positioned over the nano-AF (left and middle panel) and for remote measurement (right panel). Tunnel current setpoints considered were in a range between 3 pA and 50 pA at −3 mV for direct measurement and between 125 pA and 1 nA at −5.2 mV for the remote measurement. Tip positions are indicated as white stars in the respective topographies. (b) Nano-AF switching rates acquired as a function of tunnel current setpoint. Rates acquired using direct measurements over a central atom of the nano-AF are plotted as circles, with the 0 to 1 transition rate in red and the 1 to 0 transition rate in orange (average data acquired at −5.2 mV and 5.2 mV). Rates acquired using remote measurements are plotted as circles, with the 0 to 1 transition rate in dark blue and the 1 to 0 transition rate in light blue (both acquired at −5.2 mV). The reported error bars are the statistical errors for rate determination in a finite time measurement, i.e. several time traces of 500 seconds length, and taking into account the finite bandwidth of our instrument.51 Solid lines are fit curves using the power law dependence described in the main text; their relative confidence interval of ±σ is reported as shaded areas (see ESI S9† for fit parameters).
turbations by the presence of the sensor spin may be accomplished by placing the sensor farther away, but the reduced interaction strength will also reduce the signal magnitude and may preclude sensing. The dynamical decoupling demonstrated here minimizes the perturbation even for strong interaction with the sensor while maintaining large signal to noise ratios. This approach should in principle be possible with other interactions on other surfaces.

The primary source of measurement perturbation which remains in our sensing scheme is hot electron diffusion through the substrate. Due to this effect, the observed switching rates depend on the current setpoint, Fig. 4b: reducing the tunnel current setpoint results in a decrease in the observed switching rates. A similar trend occurs when measuring on the nano-AF, due to direct electron injection. Nonetheless, the effect of hot electron diffusion is much less pronounced than that of direct electron injection, with remote measurements yielding 100 times lower switching rates. In particular, for the lowest current setpoints the switching rate no longer depends on the current, to within our measurement uncertainty. This is a signature of the system reaching its intrinsic switching rate, which is solely determined by environmental perturbations in the Cu2N/Cu(100) sample.

The intrinsic switching rate of the nano-AF cannot be measured directly as any measurement must be considered potentially invasive. In order to estimate the intrinsic lifetime of the nano-AF we fit the switching rates observed using both methods with a power-law function of the form \( r(I) = IR^\alpha + r_0 \), and extrapolate to \( I = 0 \). \( r_0 \) is the intrinsic switching rate of the nano-AF in the absence of a measurement and \( I \) is the tunnel current. \( m \) determines the strength of the current-induced switching and we find it to be smaller by a factor of 10⁶ for the indirect measurement. The exponent \( \alpha \) accounts for single and multiple electron excitation processes, which have been reported previously.\(^{49} \) \( \alpha = 2.6 \pm 0.2 \) is observed for the indirect measurement. This indicates that switching is introduced by multi-electron processes, which can be a result of the spin pumping mechanism used for the measurement of the spin sensor. The sensor transduces state occupation of the nano-AF into a conductance change measurable by conventional \( dI/dV \) spectroscopy. Removing the STM tip spatially from the nano-AF minimizes perturbations dramatically. This permits non-local scanning tunneling spectroscopy measurements to be performed at tunnel current setpoints of 100 pA, with perturbation comparable to that of a direct measurement at tunnel currents of 20 fA. Crucially, the sensor must operate at bias voltages below the spin excitation threshold of the sensed object.

In this work, we identify the tunnel current to be the dominant source of perturbation, suggesting that this effect will be relevant in all other STM-based spin sensing techniques, e.g. electron–spin resonance spectroscopy\(^{18} \) and even in spin-polarized measurements using non-magnetic superconducting tips.\(^{50} \) Achieving non-perturbative readout of spin states is a key step in the realization of atomic and molecular spintronics. This experiment presents a method of vastly reducing the invasiveness of spin sensing and enables minimally invasive measurements of extremely sensitive atomic-scale magnetic structures in a scanning tunneling microscope.

### Abbreviations

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<th>Abbreviation</th>
<th>Description</th>
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<tr>
<td>STM</td>
<td>Scanning tunneling microscopy</td>
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<td>( dI/dV )</td>
<td>Differential conductance of the tunnel junction</td>
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<td>nano-AF</td>
<td>Nano-antiferromagnet</td>
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<td>Cu2N</td>
<td>Copper nitride</td>
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### Author contributions

The manuscript was written through contributions of all authors. All authors have given approval to the final version of the manuscript.

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### Conflicts of interest

There are no conflicts to declare.

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